# Metalurgies for wire bonding Ulrasonic ,Thermosonic and Thermocompression

- -Plating processes
- -Gold based metalurgies
- -Aluminium based metalurgies
- -Other metals
- -Other interconnection techniques
- -Long term reliability
- -Examples

# Plating processes

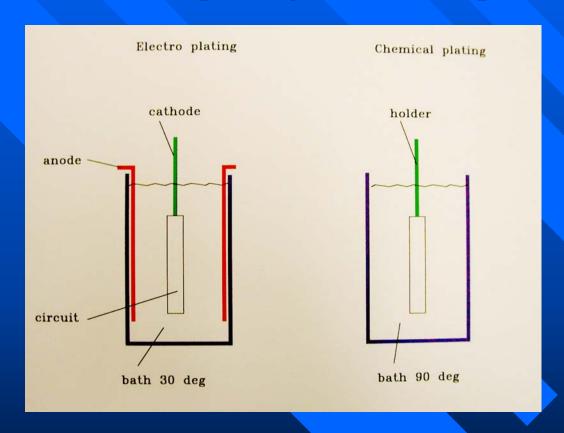
Electro & Chemical plating

Vacuum plating

Thick film plating

Layout/patterns

# Electro-plating/Chemical -plating



#### Electro plating

- -Plate only on metals
- -Metal in salts or directly the electrodes
- -Metals thickness depends on time/temp/current

#### Chemical plating

- -Plate only catalysed metals
- -Metal in salts
- -Deposition by immersion or autocatalytic
- -thickness is not fully temperature and time dependent

# Electroplating bath



Gold bath (electro plating) Ni, Au, Cu, Pd, Ag

The bath can be re-used by replenisching with salts or changing the anodes Rayon X

Anode Cathode



# Chemical plating bath

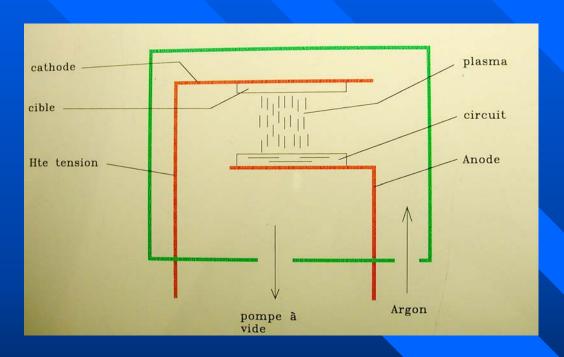


Gold bath (chemical plating)

Ni, Au, Pd, Cu

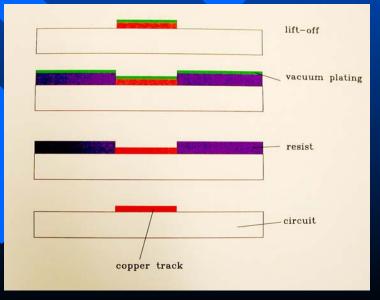
You can deposit around 6 to 10 times the metal present in one bath The bath start to be instable after that.

# Vacuum plating



- -Amorphous deposition
- -Metals deposited :Ni,Cu,Al,Au,TI,Pd etc
- -Ductility depends on Argon pressure

#### Lift-off



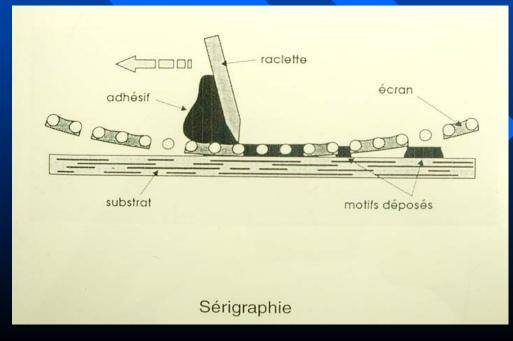
# Screen printing plating 1/2

Screen printing machine



Screen: stainless steel mesch





# Screen printing plating 2/2

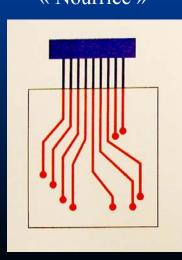


Firing :belt oven

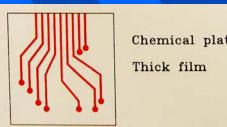
Metals: Thick Au, Ag, PtAu, PdAu
Special Gold alloys for reduced Kirkendall effects

# seed layer resist plating stripping etching

# Seed layer Electro plating « Nourrice »

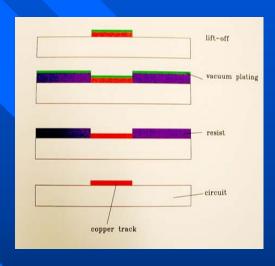


# Layouts/Patterns



Chemical plating

Direct plate or print Chemical plating Thick film



Lift-off or etching



# Gold based platings 1/2

Туре	Thicknesses (um)	Plating type
Ni/Au	5/0.05-0.1	chemical
Ni/Pd/Au	5/0.3/0.05-0.1	chemical
Ni/ Thick Au	5/1	chemical/electro
Au Cobalt	3	electro
Chemical Au	0.05-0.1	chemical
Electro Au	1.5-2	electro
Ni/Au Vacuum	2/1	sputtering
Au thick film	8-15	Screen printing

# Gold based platings 2/2

Plating	Al bonding	Au bonding	contact	Press fit	Solder
Ni/Au	OK	NO	NO	OK	OK
Ni/Pd/Au	OK	OK	NO	OK	OK
Ni/Thick Au	OK	OK	NO	OK	OK*
Au cobalt	NO	NO	OK	OK	NO
Chemical Au	NO	NO	NO	NO	OK
Electro Au	OK/NO	OK/NO	NO	NO	OK*
Ni/Au vacuum	OK	ОК	NO	NO	OK*
Au thick film	OK	OK	NO	NO	NO

<sup>\*</sup> Ok but not recomanded

# Aluminium based platings

Aluminium type	Thicknesses (um)	Wedge Al	Ball Au
Sheet 99.9 %	15-50	OK	OK
Vacuum evaporation	1.5-2 mini	OK/NO	OK/NO
Vacuum sputtering	1.5-2mini	OK*	OK*
Al/Si sputtering (1-2%)	1.5-2mini	OK*	OK*
Al/Cu sputtering(1-3%)		OK*	OK*

<sup>\*</sup> Depend on the parameters during the process

#### Other metals

- -Cu  $\rightarrow$  bondable but not reliable
- -Ag  $\rightarrow$  bondable but not reliable
- -Cr  $\rightarrow$  difficult to bond due to passivation
- -Pt Au → bondable but not as good as Gold
- -Pd or Ni/Pd → Seem to be as good as Gold but not very used (chemical & electro)

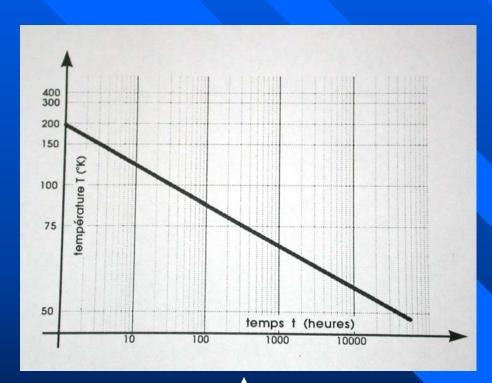
# Other interconnections techniques with similar processes as wire bonding

- -TAB (tape automated bonding)

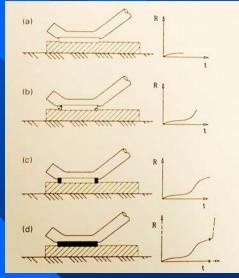
  Thermocompression Au/Au or Au/Sn
- -Bump bonding
  Thermocompression Au/Au (C4 or ball bumps)
- -SMD component bonding
  Ultrasonic SnPb/SnPb

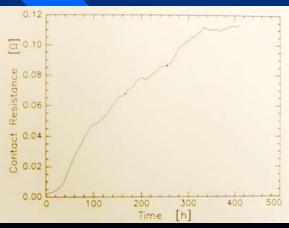
# Long term reliability 1/3

#### Kierkendall effect (Al to Au bond)



### Kirkendall voids evolution





# Curve X=cte

$$x = \sqrt{t \cdot k_0 \cdot e^{\frac{-E}{K \cdot T}}}$$

X=thickness of AuAl2

t= Time

T=Temperature

K=Boltzmann constant

# Long term reliability 2/3

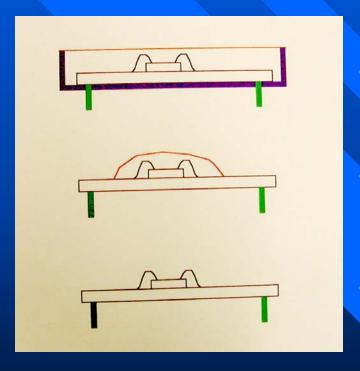
Kirkendall voids observed in 2 cases:

-Aluminium bonding on thick gold pads (1 to 15um) Not on immersion gold (0.05um)

-Gold bonding on Aluminium pads

No information on intermetallics with Pt/Au or Pd

# Long term reliability 3/3



- Sealed package withNitrogen without humidity
- Glass epoxy Glob-top, silicon gel, Polyimide glob-top.
  - Sensitive to CTE mismatch
- No protection, need a controlled atmosphere and no humidity

# Examples

